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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Tsuneyuki OKABE, et al.

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For: SEMICONDUCTOR MANUFACTURING APPARATUS AND
SEMICONDUCTOR MANUFACTURING METHOD

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to or concurrent with calculation of the filing fees, please amend this application as follows.